

<b>Notice of References Cited</b>		Application/Control No. 09/885,527	Applicant(s)/Patent Under Reexamination KIM ET AL.	
		Examiner David Y. Chung	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-6,255,130	07-2001	Kim, Dong-Gyu	438/30
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**NON-PATENT DOCUMENTS**

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